

Abstract Submitted
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Role of the three Si suboxides at the surface of Si quantum dots and in Si/SiO₂ quantum wells on optical response¹ PIERRE CARRIER, University of Minnesota — The Si/SiO₂ interface structure has been extensively studied in the past, especially for MOSFET applications. Recent applications of Si/SiO₂ nanostructures in solar cells and LEDs are now investigated using Si quantum dots (QD) or Si/SiO₂ quantum wells (QW). The Si/SiO₂ interface contains three Si suboxides, each bonded to 1, 2, or 3 oxygen atoms, respectively referred to as Si¹⁺, Si²⁺, and Si³⁺. Models that contain all three suboxides are difficult to construct; results in the literature on oxygenated Si QD usually include Si¹⁺ and Si²⁺ only. The models presented here contain the 3 suboxides and are based on a Si/SiO₂ surface model originally constructed by Pasquarello *et al.*, Appl. Phys. Lett. **68**, 625 (1996). This model was used later by the author in the study of Si/SiO₂ QW [Phys. Rev. B **65**, 165339 (2002)] and is now extended to Si QD. It is shown that the band gap or optical response depends strongly on the Si suboxide atomic configuration at the surface of QD or at the interface of QW. Trends on the band gap variations as function of the three suboxides will be discussed. All models (QW and QD) are structurally relaxed using the program PARSEC [Phys. Rev. Lett. **72**, 1240 (1994)].

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